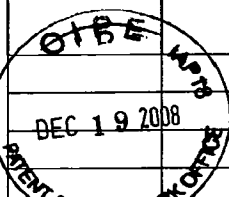


<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT PTO-1449</b>	Docket No. <b>52433/783</b>	Application No. <b>10/518,664</b>	
	Applicant(s) <b>Akira Usami et al.</b>	Examiner <b>Deborah YEE</b>	
	Filing Date <b>December 17, 2004</b>	Confirmation No. <b>7856</b>	Art Unit <b>1793</b>

## U. S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT/PUBLICATION NUMBER	PATENT/PUBLICATION DATE mm/dd/yyyy	NAME	CLASS	SUBCLASS	FILING DATE
						

## FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE mm/dd/yyyy	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						Yes	No
/D.Y./	2001-214236	08/07/2001	JP			Abstract	
/D.Y./	2001-123243	05/08/2001	JP			Abstract	
/D.Y./	01-149923	06/13/1989	JP			Abstract	
/D.Y./	2000-017381	01/18/2000	JP			Abstract	
/D.Y./	52-011118	01/27/1977	JP			Abstract	

## OTHER DOCUMENTS

EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.
	Japanese Office Action dated October 21, 2008 issued in corresponding Japanese Application No. 2003-138374. English translation required

EXAMINER	/Deborah Yee/	DATE CONSIDERED	03/12/2009
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.			